Express Mail: EM 083176878 US

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.:

6.998.625

Issue Date:

February 14, 2006

Title:

Ion Implanter Having Two-Stage Deceleration Beamline

Assignee: Varian Semiconductor Equipment Associates, Inc. Inventors: Charles M. McKenna et al.

Inventors: Art Unit:

2881

# STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP

Sir:

I, CHARLES M. MCKENNA, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: Sept. 14, 2007

Charles M. McKenna

Docket No. 99-005 Express Mail: EM 083176878 US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.:

6.998.625

Issue Date:

February 14, 2006

Title:

Ion Implanter Having Two-Stage Deceleration Beamline

Assignee:

Varian Semiconductor Equipment Associates, Inc.

Inventors:

Charles M. McKenna et al.

Art Unit:

2881

## STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP

Sir:

I, NICHOLAS R. WHITE, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: 8/30/0/

Nicholas R. White

Express Mail: EM 083176878 US

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.:

6,998,625

Issue Date:

February 14, 2006

Title:

Ion Implanter Having Two-Stage Deceleration Beamline

Assignee: Varian Semiconductor Equipment Associates, Inc.

Inventors: Art Unit:

Charles M. McKenna et al. 2881

#### STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP

Sir:

I, DOUGLAS A. BROWN, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: 11 October 2007

Express Mail: EM 083176878 US

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.:

6.998.625

Issue Date:

February 14, 2006

Title: Assignee: Ion Implanter Having Two-Stage Deceleration Beamline Varian Semiconductor Equipment Associates, Inc.

Inventors:

Charles M. McKenna et al.

Art Unit:

2881

## STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP

Sir:

I, EDWARD BELL, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: 8/29/87

By: Edward Ball

Express Mail: EM 083176878 US

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.:

6.998.625

Issue Date:

February 14, 2006

Title:

Ion Implanter Having Two-Stage Deceleration Beamline

Assignee:

Varian Semiconductor Equipment Associates, Inc.

Inventors:

Charles M. McKenna et al.

Art Unit:

2881

# STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP

Sir:

I, SVETLANA RADOVANOV, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: 8/28/07

Svetlana Badovanov